Applicant : Shinji Maekawa

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit: 2813

Serial No.: 09/724,403 Examiner: Yennhu B. Huynh

: November 27, 2000 Filed

Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE

SAME

Commissioner for Patents Washington, D.C. 20231

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Official Action mailed January 29, 2001, Applicant elects the invention of Species I: claims 1-32, drawn to a method of manufacturing a semiconductor device. election is made without traverse.

AMENDMENT

Kindly amend the above-referenced application as foll & s.

In the Claims:

Please amend the claims as follows.

(Amended) A method of manufacturing a semiconductor

04/15/2002 GGEBREGI 00000025 09724403

01 FC:103

02 FC:115

288.00 OP

110.00 OP

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